



JSW

XA-9907  
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Haruki FUKAI et al.

Appln. No.: 10/616,923

Group Art Unit: 2828

Filed: July 11, 2003

Examiner: J. Menefee

For: SEMICONDUCTOR LASER, MANUFACTURING THE SAME AND  
SEMICONDUCTOR FOR LASER DEVICE

\* \* \*

RESPONSE

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

Responding to the Office Action mailed March 29, 2005,  
and to the requirement for restriction therein, Applicants  
elect Group II (Claims 6-14) without traverse, reserving  
the right to file a divisional application with regard to  
the non-elected invention.


An action on the merits of the claims to the elected  
invention is respectfully requested.

The Commissioner is hereby authorized to charge to  
Deposit Account No. 50-1165 any fees under 37 C.F.R. §§1.16  
and 1.17 which may be required by this paper, and to credit

any overpayment to that Account. If any extension of time is required in connection with the filing of this paper and has not been requested separately, then such extension is hereby requested.

Respectfully submitted,

By:

  
\_\_\_\_\_  
Mitchell W. Shapiro  
Reg. No. 31,568

MWS:kss

Miles & Stockbridge P.C.  
1751 Pinnacle Drive  
Suite 500  
McLean, Virginia 22102  
(703) 903-9000

April 29, 2005